

I hereby certify that this correspondence is being sent by facsimile to 1-571-273-8300 addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date shown below.  
Dated: May 28, 2008 Signature: Eileen Sheffield  
(Eileen Sheffield)

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MAY 28 2008

Docket No.: NY-RPP-202  
(10510421)  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:  
**BECKMANN**

Application No.: 10/552,677

Group Art Unit: 1792

Filed: November 21, 2005

Examiner: N. K. Ford

For: **HIGH FREQUENCY PLASMA JET SOURCE  
AND METHOD FOR IRRADIATING A  
SURFACE**

**RESPONSE TO RESTRICTION REQUIREMENT AND AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Responsive to the restriction requirement mailed April 30, 2008, Applicants elect to prosecute the claims of Group I, claims 26-43, 54 and 55. Additionally, please amend the application as follows: